Electrical Percolation during Codeposition of Fe and Si Clusters by a Dual Source PGCCD System

Nobuyuki Shinohara*, Ryoji Katoh and Kenji Sumiyama

Department of Materials Science and Engineering, Nagoya Institute of Technology, Nagoya 466-8555, Japan

Random assemblies of Fe and Si clusters have been prepared using a dual source plasma gas condensation cluster deposition system and their conductivities were measured for various compositional ratios. The size distributions of Fe and Si clusters are obtained by transmission electron microscopy (TEM) observations and the volume fraction of Fe clusters, \( f_{Fe} \), is estimated from the chemical analysis and packing fraction of cluster assemblies. Electrical conductivity, \( \sigma \), of Fe and Si cluster assemblies obeys a power law of \( f_{Fe} \). The dramatic change at around \( f_{c} = f_{c}^{c} \) indicates that the percolation of Fe clusters takes place at the threshold value, \( f_{c}^{c} = 0.16 \). It is consistent with the Links-Nodes-Blobs model calculated for a three dimensional percolation network. [doi:10.2320/matertrans.MBW200708]

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1. Introduction

Anomalous and functional properties of nanostructure-controlled materials are interesting topics in materials science and technology. They have been usually made from supersaturated solution via low temperature heat treatment. In such precipitation processes, the particle size and inter-particle distance cannot be adjusted independently owing to the materials balance.1) Assembling of clusters is an alternative method for fabricating nanostructured materials because nanometer sizes of clusters are the same as elemental units of materials’ structures and functionalities. The size uniformity, stability against oxidation and suppression of inter-cluster aggregation are requisite to utilize the size-dependent characteristics of clusters.

Using a plasma-gas-condensation cluster deposition (PGCCD) system, we have prepared mono-disperse size transition metal clusters whose mean diameters, \( d \), range between 5 and 15 nm with the standard deviation less than 10% of \( d \).2) When such clusters are continuously deposited on a substrate in the PGCCD system, their numbers are increased while their sizes are maintained. With further increasing the deposition time they agglomerate to form geometrical and electrical networks. These features can be well understood as percolation phenomena.

In the next step, preparation and deposition of different kinds of clusters are interesting challenges. They are analogous to alloying of two elements in metallurgy, which has given a lot of high functional alloys and displayed the prosperity of materials. For this purpose we developed a PGCCD system which had two glow discharge sources: one glow discharge was a dc mode and the other an rf or dc discharge mode: two sputtering chambers were divided by a simple plate which could separate two glow discharges and two kinds of vapor atoms sputtered out of the targets. When the separation plate was inserted between two glow-discharge chambers, a mixture of Fe and Si clusters was obtained on a substrate: small Fe clusters were distributed at random, while the Si clusters were aggregated to form large secondary particles. Without inserting the separation plate, on the other hand, core-shell clusters were obtained: Fe core were surrounded by small Si crystallites.3,4) These results indicate that Fe and Si clusters do not merge to form alloy- and compound-clusters though the chemical affinity of Fe and Si is so high as to form very stable intermetallic compounds in the equilibrium phase diagram.5,6)

In order to perform better control of cluster-preparation and -deposition processes we have recently developed a dual source PGCCD system. In this study, we codeposited Fe and Si clusters using this new PGCCD system. We carried out transmission electron microscope (TEM) observations of Fe and Si clusters codeposited on TEM microgrids. We also did in-situ observations of electrical conductivity during codeposition processes of Fe and Si clusters on glass substrates to discuss their percolation behaviors.

2. Experimental

Figure 1 shows a newly developed dual source PGCCD system, which consists of two DC glow discharge sources installed in the completely separated sputtering chambers.
two cluster growth rooms, intermediate evacuation chambers and a deposition room. All of them were first evacuated down to $10^{-5}$ Pa by turbo molecular and composite molecular pumps, TMP and CMP. In the PGCCD system, which was a hollow cathode type, two Fe and two Si plates of 80 mm in diameter and 5 mm in thickness were set on two target holders, where Fe was 99.9% pure and Si was n-type doped of 10 ppm B for DC sputtering. Since magnetic field was applied perpendicular to these targets and its intensity at the perimeter was higher than the one at the center, the metal plates were rather uniformly and efficiently sputtered out in contrast to non-uniform target erosion of conventional magnetron sputtering.

For glow discharge sputtering TMPs were shut down and a large amount of Ar gas (99.9999 vol.%) was independently introduced through gas-inlets with adjusting mass flow meters, while growth rooms were evacuated by a mechanical booster pump (800 m$^3$/h) to eject the Ar gas, sputtered atoms and formed clusters through the small nozzle of intermediate evacuation chambers. Here, the Ar gas flow rates were 6.7 $\times$ 10$^{-6}$ m$^3$/s: the corresponding Ar gas pressure of the sputtering chambers 1 and 2 was 270 Pa, while that of the deposition chamber was 0.3 Pa by the TMP evacuation. The input electric powers for the glow discharge were as follows: the electric current was 1.00 A, and the voltage between 300–350 V for the Fe targets and 400–450 V for the Si targets. The thickness of the deposited cluster assembly, $t$, was measured with a stylus instrument (SURFCM1400D). In this study we first prepared and deposited only Fe and Si clusters on substrates by operating one of the dual glow discharge sources, and then Fe and Si clusters simultaneously on a substrate by operating the dual glow discharge sources.

The morphology, size and structure of Fe, Si and Fe/Si clusters were observed using a transmission electron microscope (TEM; Hitachi Co., HF-2000) operating at 200 kV. TEM images were observed for specimens on TEM grids at the initial deposition stage and selected area electron diffraction patterns for those at the late deposition stage. The cluster size distributions were determined from digitized images recorded by a slow-scan charge-coupled device camera for the area of $350 \times 350$ nm$^2$ using the image-analysis software (Image-Pro PLUS: Media Cybernetics).

During the deposition of clusters an electrical current was measured between two stripe electrodes on a glass substrate (the widths of 2 mm and the separation distance of 0.5 mm) with application of an electric voltage of 0.1 V using a digital multimeter (Keithley2400,236).

Compositional ratios, Fe/Si were determined by energy dispersive X-ray (EDX) analyzers installed both in TEM and in a scanning electron microscope (SEM) (Hitachi S-4700) operating at 5 kV, where the O content was neglected owing to the quantitative resolution limit.

3. Result

Figure 2(a) shows a bright-field TEM image of Fe clusters and (c) the size distribution histogram estimated from Fig. 2(a), indicating that the cluster sizes are distributed between 5 and 15 nm: the average Fe cluster size is about 9.3 nm and the standard deviation is about 27%. As shown in
Fig. 2(b) (the selected area diffraction patterns of the Fe clusters), bcc (α-Fe) and Fe$_3$O$_4$ type diffraction rings are detected, indicating the partial oxidation of Fe clusters.

Figure 3(a) shows a bright-field TEM image of Si clusters and Fig. 3(c) the size distribution histogram estimated from Fig. 3(a), indicating that the cluster sizes are widely distributed between 5 and 40 nm: the average Si cluster size is about 16.5 nm and the standard deviation is about 51%. Figure 3(a) also shows that the large Si particle consists of small crystalline particles. As shown in Fig. 3(b) (the selected area diffraction patterns of the Si clusters), diamond type diffraction rings are detected whereas their widths are very broad. The high-resolution TEM image of Si clusters shown in Fig. 3(d) demonstrates that a Si cluster is a secondary aggregate and contains much smaller crystallites.

Figures 4(a) and (b) show a bright-field TEM image and the selected area diffraction patterns of Fe and Si clusters codeposited under the same conditions as those for Figs. 2 and 3. In Fig. 4(a) the size distribution of these clusters are remarkable, whereas Fe and Si clusters are not markedly coalesced each other. In Fig. 4(b), the electron diffraction rings indicated by arrows can be indexed as bcc-α-Fe, Fe$_3$O$_4$ and diamond-type Si phases being similar to those of Fe and Si clusters in Figs. 2(b) and 3(b). However, no clear diffraction ring corresponding to intermetallic compounds, Fe$_3$Si, FeSi$_2$, etc. cannot be detected.

Figures 5(a), (b) and (c) show changes of electrical current (I) as a function of the average deposition thickness of Fe, Si and Fe and Si clusters, t, which were observed between two electrodes on substrates during deposition of Fe and Si clusters, and codeposition of Fe and Si clusters. For deposition of Fe clusters (Fig. 5(a)), I is negligibly small for $t < 23$ nm. It rather suddenly starts to increase at $t = 24$ nm and nonlinearly increases for $t > 24$ nm, suggesting a two dimensional electrical percolation. With further increasing $t$, I linearly increases with increasing $t$ for $t > 35$ nm. Similarly for deposition of Si clusters in Fig. 5(b), I = 0 A for $t < 51$ nm and it starts to increase at $t = 52$ nm, while the non-linear change is observed for $t = 52$–400 nm and the linear change for $t > 400$ nm. For codeposition of Fe and Si clusters whose compositional ratio, Fe/Si = 60/40 in Fig. 5(c), I = 0 A for $t < 32$ nm and it start to increase at $t = 33$ nm. Two step changes are detected: a non-linear one for $t = 33$–150 nm and a linear one for $t > 150$ nm.

Taking account of the thickness and area of cluster assemblies on a substrate, we estimated the electrical conductivity, $\sigma$. Table 1 shows $\sigma$ values of Fe and Si cluster assemblies in comparison with those of bulk specimens. $\sigma$ of the Fe cluster assembly is 50 times smaller than that of bulk specimens, probably due to their porous stacking, while $\sigma$ of Si cluster is 1200 times larger than that of bulk specimens due to the heavy doping of Si targets. Here, it is worth to emphasize that $\sigma$ of the Fe cluster assembly is a six order larger than $\sigma$ of the Si cluster assembly.
Table 1  Electrical conductivity, $\sigma$ (1/$\Omega$m), of Fe cluster- and Si cluster- assemblies together with their bulk specimens.

<table>
<thead>
<tr>
<th></th>
<th>cluster assembly</th>
<th>bulk</th>
</tr>
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<tbody>
<tr>
<td>Fe</td>
<td>$1.92 \times 10^3$</td>
<td>$9.93 \times 10^6$</td>
</tr>
<tr>
<td>Si</td>
<td>$3.04 \times 10^{-1}$</td>
<td>$2.52 \times 10^{-4}$</td>
</tr>
</tbody>
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Fig. 6  Electrical conductivity, $\sigma$, of Fe and Si cluster assemblies as a function the average Fe composition.

Figure 6 shows $\sigma$ versus the Fe composition (at%) in codeposited assemblies of Fe and Si clusters, whose average thicknesses were more than 200 nm. Here, the Fe compositions were estimated by the EDX analyzer in SEM. Since the central positions of Fe and Si cluster beams were not so well coincided, the dispersion in Fe compositions among a specimen was almost 5 at%.$\sigma$ is very low, being less than $0.5 \Omega^{-1}.m^{-1}$ for Fe/Si < 60/40 while it rapidly increases for Fe/Si > 60/40.

4. Discussion

Figures 2(c) and 3(c) reveals that the size distribution of Si clusters is wider than that of Fe clusters and Figs. 2(a) and 3(d) reveals that the primary crystalline size of Si clusters are much smaller than that of Fe clusters. These results are consistent with the Gibbs and Thomson criterion for nucleation of a small substance.$^7$ Si clusters are more stable than Fe clusters in their small size ranges because the surface energy of Si is about a half of that of Fe. In the growth rooms, such small primary Si crystallites collide with each other and agglomerate to form secondary particles.$^8$ Since they are oxidized after exposing to ambient atmosphere, the very broad diffraction rings of Si clusters can be ascribed both to the small crystalline sizes and to formation of deficient silicon mono-oxides that have amorphous-like structures.

Fe and Si clusters formed in high Ar gas atmosphere of the present dual source PGCCD system are well thermalized via many time collisions with Ar atoms in the growth rooms. After passing through the nozzles and skimmers, these clusters do not collide with each other so often and impinge on the substrate because the vacuum condition becomes much better. This speculation is supported by the low deposition rate of clusters (the maximum rate is 1.1 nm/sec.). The velocities of 10 nm size Fe and Si clusters are the same order of magnitude as that of Ar gas flow velocity, which is at most a sound velocity when it pass through the nozzle between the growth room (its Ar gas pressure is about 200 Pa.) and the intermediate evacuation room (its Ar pressure is about 2 Pa.) Since the kinetic energy of impinging clusters onto the substrate surface is about a few hundred eV, the clusters can migrate on the substrate.$^9$ However, the clusters of about 10 nm in diameter contain several ten thousands of atoms and the kinetic energy per atom is an order of $10^{-3} - 10^{-2}$ eV, being much smaller than the cohesive energy of Fe, Si and Fe-Si compounds. Even if such clusters collide with each other and impinge on the substrate, their fragmentation and merging cannot be expected at Fe and Si cluster interfaces, and Fe and Si clusters randomly coexist on the substrate, as shown in Fig. 4(a).

As shown in Figs. 5(a), (b) and (c), the $I$ versus $t$ curves reveal the two step changes. At the initial stage $I$ is negligibly small, indicating that the two electrodes are not electrically connected by a network of clusters. The sudden increase in $I$ at a certain value of $t$, suggests a threshold of two dimensional electrical percolation, whose schematic image is shown in Fig. 7(a). The data of non-linear $t$ dependence of $I$ have been fitted to the following scaling law,

$$I \propto (t - t_c)^\mu,$$

where $t_c$ is the critical thickness and $\mu$ the critical exponent, being the fitting parameters.$^9$ In the previous studies on the deposition of uniform size Co clusters, we discussed the size dependence of the percolation phenomena and interpreted by the soft percolation model.$^{11}$ In the present study, however, we do not study a detailed size-dependence in the two dimensional percolation because the size uniformities of Fe and Si clusters are not so good as those of Co clusters prepared by the single source PGCCD system.

Then, we pay attention to the $t$ linear dependence of $I$ for heavily stacked specimens in Fig. 5 because it clearly indicates a three dimensional connection of these clusters,

Fig. 7  Schematic images of (a) a two dimensional electrical percolation threshold and (b) a three dimensional connection of clusters assemblies.
whose schematic image is shown in Fig. 7(b). Since Fe is a metal and Si is a semiconductor, the electrical conductivity of Fe and Si cluster assemblies are so different as mentioned in Table 1. Figure 6 also demonstrates that $\sigma$ changes dramatically at around the deposition ratio of Fe/Si = 60/40: a Si cluster network predominates for Fe/Si < 60/40, while a Fe cluster network for Fe/Si > 60/40.

In order to understand the three dimensional percolation in the present codeposited assemblies of Fe and Si clusters, we introduce the following power law proposed for the mixed assembly of metal and insulator particles:

$$\sigma \propto (f - f_c)^\alpha (f > f_c)$$

$$\sigma \propto (f_c - f)^\beta (f < f_c),$$

(2)

where $f$ is the volume fraction of metal particles, $f_c$ the critical value of $f$, and $\alpha(>0)$ and $\beta(<0)$ the critical exponents for discussing the conductivity of these mixed assemblies. Taking into account of the random distribution in the electrical current channel for $f > f_c$, eq. (2) is rewritten by the following Links-Nodes-Blobs model:

$$\sigma \propto (f - f_c)^{(d-2)\nu+1}$$

(3)

where $d$ is a dimension of two different particles ($d = 3$ for the present case) and $\nu$ the critical exponent. Since the packing density 30–35% for the assemblies of Cr, Co, and Fe clusters prepared by previous PGCCD systems, we assume $p = 0.3$ for estimating the volume fraction of Fe clusters, $f_{Fe}$. Figure 8 shows the $\sigma$ values as a function of $f_{Fe}$ derived from Fig. 6. As shown in this figure, the model curves, choosing $f_c \approx 0.15$, $\alpha \approx -0.7$ for $f < f_c$ and $\nu \approx 0.9$ for $f > f_c$ are well fitted to the estimated results. The value of $f_c$ is close to the theoretically calculated one, $f_c = 0.15$, for a three-dimensional random lattice, while it is much different from $f_c = 0.44$ for two dimensional random lattice. Such a drastic change in $\sigma$ is a typical percolation phenomenon, demonstrating that metallic Fe clusters and semiconducting Si clusters are loosely stacked and no marked alloying behavior is induced in these Fe and Si cluster assemblies.

5. Summary

Using a newly developed dual source PGCCD system, Fe and Si clusters have been independently or simultaneously deposited on substrates. In the TEM images of codeposited assemblies of Fe and Si clusters, bcc and diamond-type phases coexist, where neither alloying nor merging of these two kinds of clusters is observed. In-situ observations of electrical conduction during deposition of these clusters demonstrate two steps changes from two dimensional to three dimensional conduction channel (networks) formations, i.e., the characteristic features of electric percolation phenomena. The conductivity versus volume fraction of Fe clusters plot also reveals the percolation phenomena for assemblies of metal Fe and semiconductor Si clusters, being well interpreted by the Links-Nodes-Blobs model.

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REFERENCES


